Application/Control No.	Applicant(s)/Patent under Reexamination
10/643,422	TANAKA ET AL.
Examiner	Art Unit
Kim-Kwok CHU	2627

SEARCHED					
Class	Subclass	Date	Examiner		
369	47.16	5/9/2007	KC		
369	44.28	5/9/2007	кс		
369	44.34	5/9/2007	кс		
369	59.25	5/9/2007	. кс		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East Search Updated	5/9/2007	кс		
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